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4-24-01

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Young-Jin KIM

Serial No.: 09/599,475 Group Art Unit: 2786

Filed: June 22, 2000 Examiner: Not Yet Assigned

For: SEMICONDUCTOR FACTORY AUTOMATION SYSTEM AND METHOD FOR MONITORING AT LEAST ONE SERVER IN REAL TIME.

RECEIVED

* APR 19 2001

INFORMATION DISCLOSURE STATEMENT

Technology Center 2100

Honorable Commissioner for Patents
Washington, DC 20231

April 18, 2001

Sir:

As a means of complying with the duty of disclosure under 37 CFR §1.56, and in accordance with 37 CFR §§1.97 and 1.98, Applicants, through the undersigned attorney, submits this Information Disclosure Statement. The patents, publications or other information submitted herewith are listed on the attached Form PTO-1449 and copies are attached.

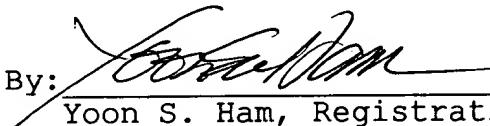
In accordance with 37 CFR §1.97(b)(3), this Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits of the above-identified application. Should any fee be required by the filing of this statement, please charge such fee to Deposit Account No. 06-1358. A duplicate copy of this paper is enclosed.

CERTIFICATION

It is hereby certified that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Respectfully submitted,

JACOBSON, PRICE, HOLMAN & STERN, PLLC

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Atty. Docket: P65689US0
Enclosures
YSH:ecl